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## BIB DATA SHEET

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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/JP05/01513 02/02/2005

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2004-032607 02/09/2004

## \*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*\* SMALL ENTITY \*\*

04/09/2007

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and /CARIDAD EVERHART/ Examiner's Signature	<input type="checkbox"/> Met after Allowance		Initials	JAPAN	6	25	3
Acknowledged							

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## TITLE

Method of manufacturing a semiconductor device and method of etching an insulating film

FILING FEE RECEIVED 575	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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